

Application/Control No.	Applicant(s)/Patent under Reexamination
10/808,964	MENG ET AL.
Examiner	Art Unit
Shanon Foley	1648

SEARCHED					
Class	Subclass	Date	Examiner		
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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SEARCH NOT (INCLUDING SEARCH)
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